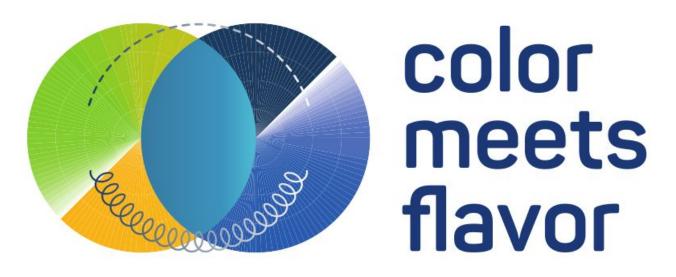




# CmF infrastructure: InCyTe Interdisciplinary Research Center for Nanoanalytics, Nanochemistry and Cyber-physical Sensor Technologies

#### Markus Cristinziani

TA1 kick-off meeting November 14th, 2025



## Core facility of the School of Science & Technology

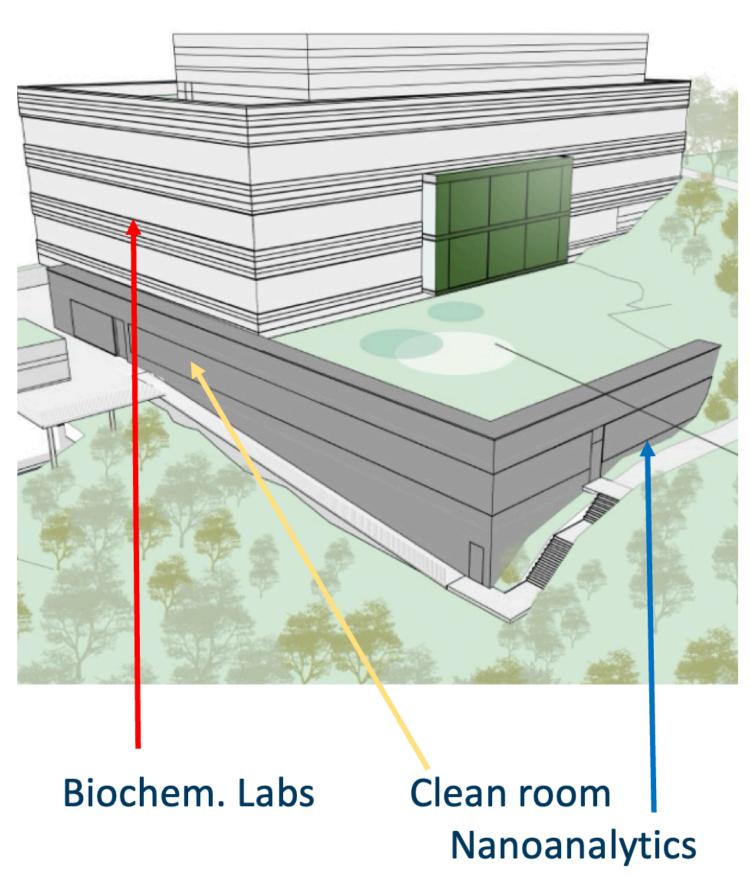


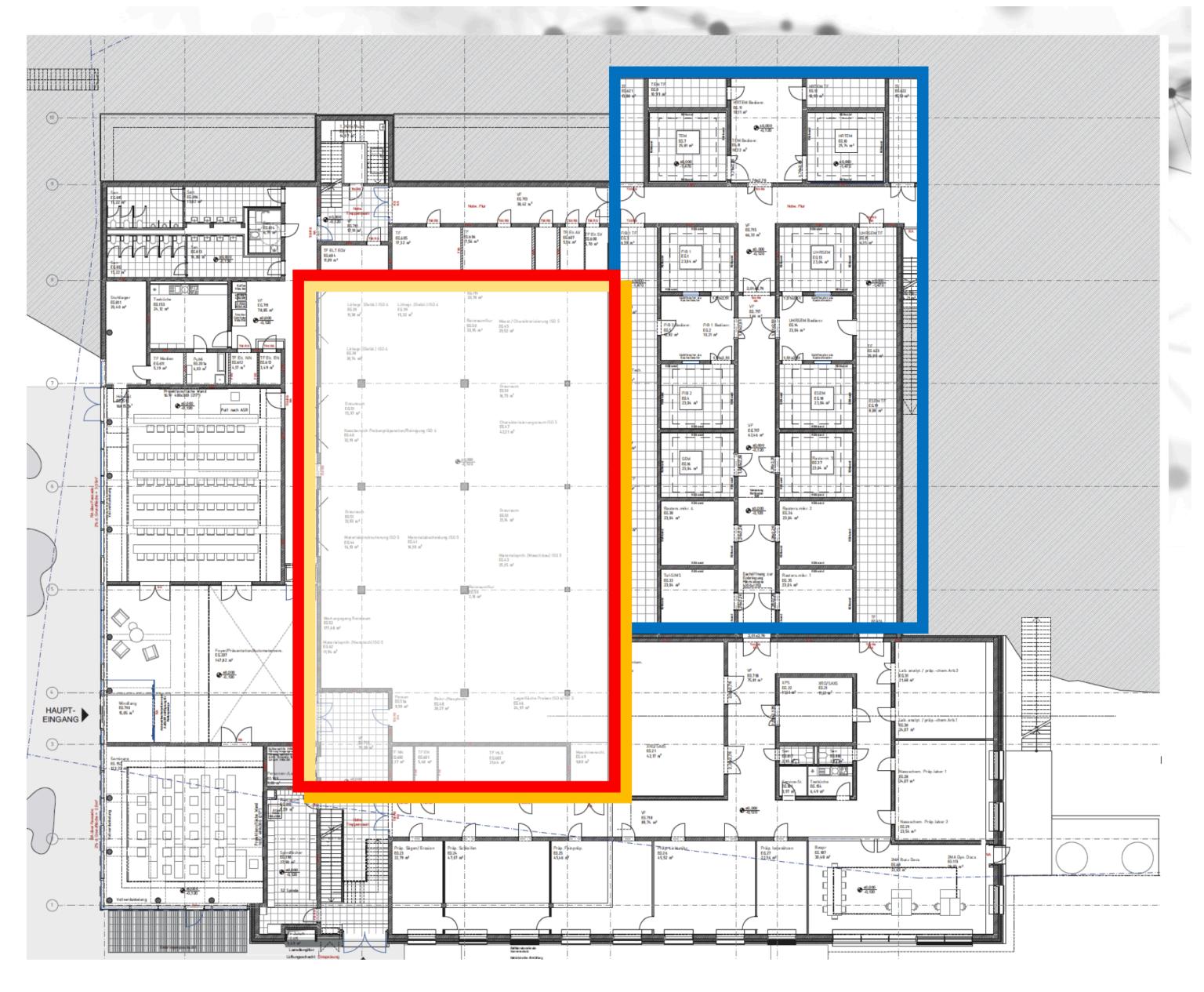






## R&D infrastructure and synergy center



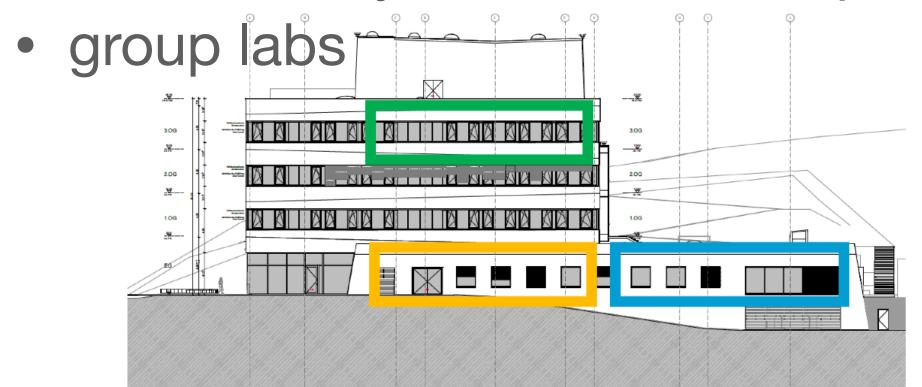




## R&D infrastructure and synergy center

#### 5.500 m<sup>2</sup>

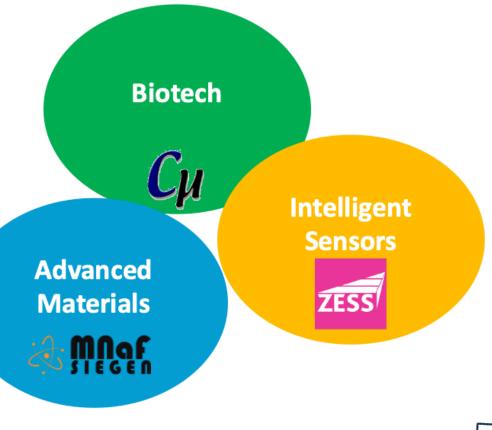
- 600 m<sup>2</sup> ISO4, 600 m<sup>2</sup> S2/S1 labs
- 7 EM-labs
- 300 m<sup>2</sup> analytics, 300 m<sup>2</sup> sample prep.







granted







## Research at INCYTE

## More than 25 groups from departments of School of Science and Technology

- Electrical engineering
- Mechanical engineering
- Chemistry
- Physics
- Computer science

#### INCYTE Research&Development

#### Nanotechnology

edge intelligent sensorics

- Advanced Imaging (3D-ToF, SPAD, THz)
- Edge Intelligence
- Structural Health Monitoring
- Quantum Computing
- Heterogeneous Integration
- 2D Materials, Organics, Perovskites, ...

#### Nanochemistry

molecular sensorics

- Molecular and Bioorganic Sensors
- Smart Surfaces
- Interface Analytics
- X-ray Holography
- Scanning Probe Sensorics
- Nano-Tomography



#### **Nanoanalytics**

advanced materials

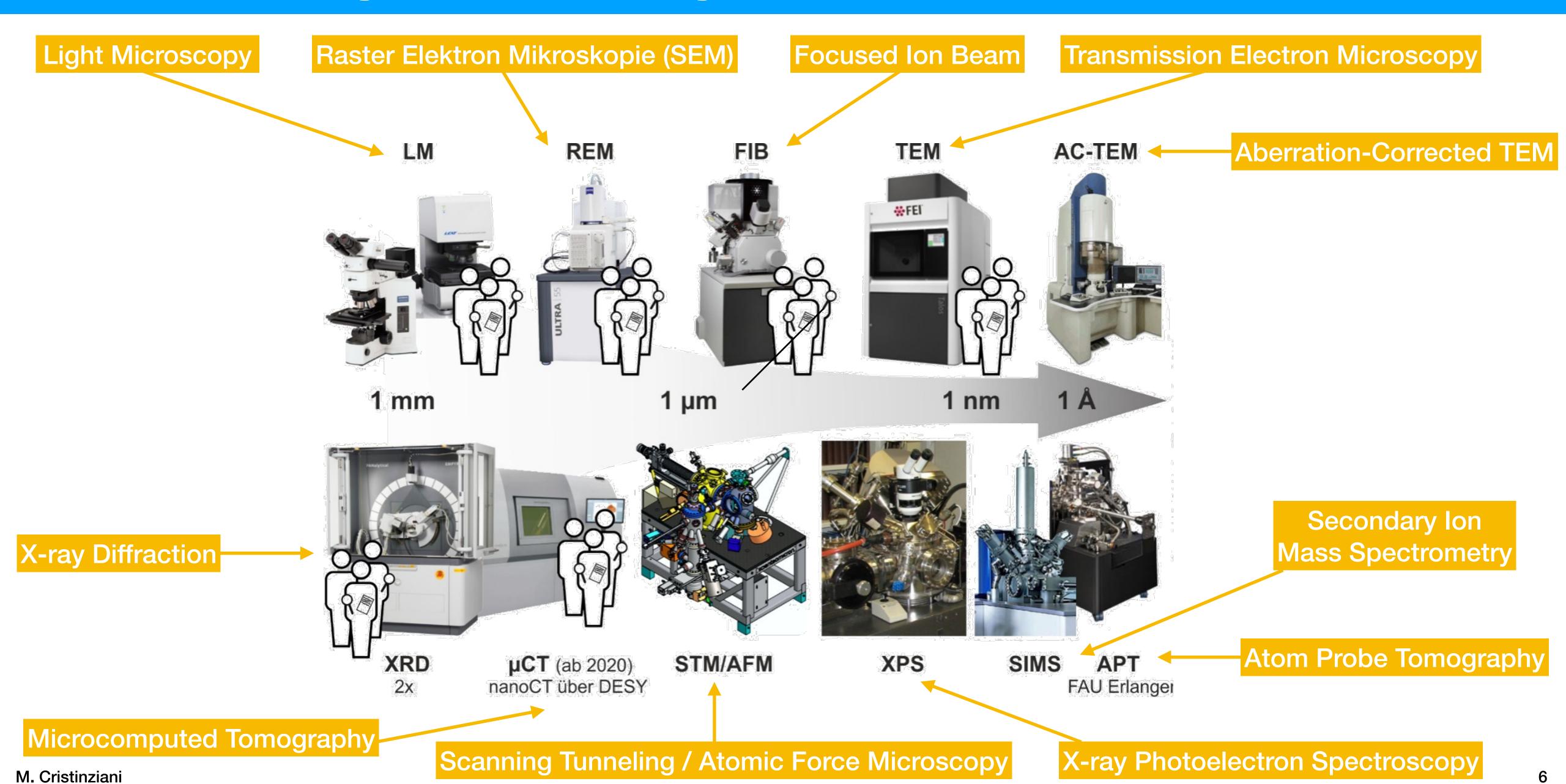
- Nanomaterials and Quantum Structures
- Gradient Materials
- Photonic and phononic Sensor Materials
- Adaptive Materials
- Composites
- Energy Storage and Harvesting



M. Cristinziani

ZESS

## Nanoanalytics facility

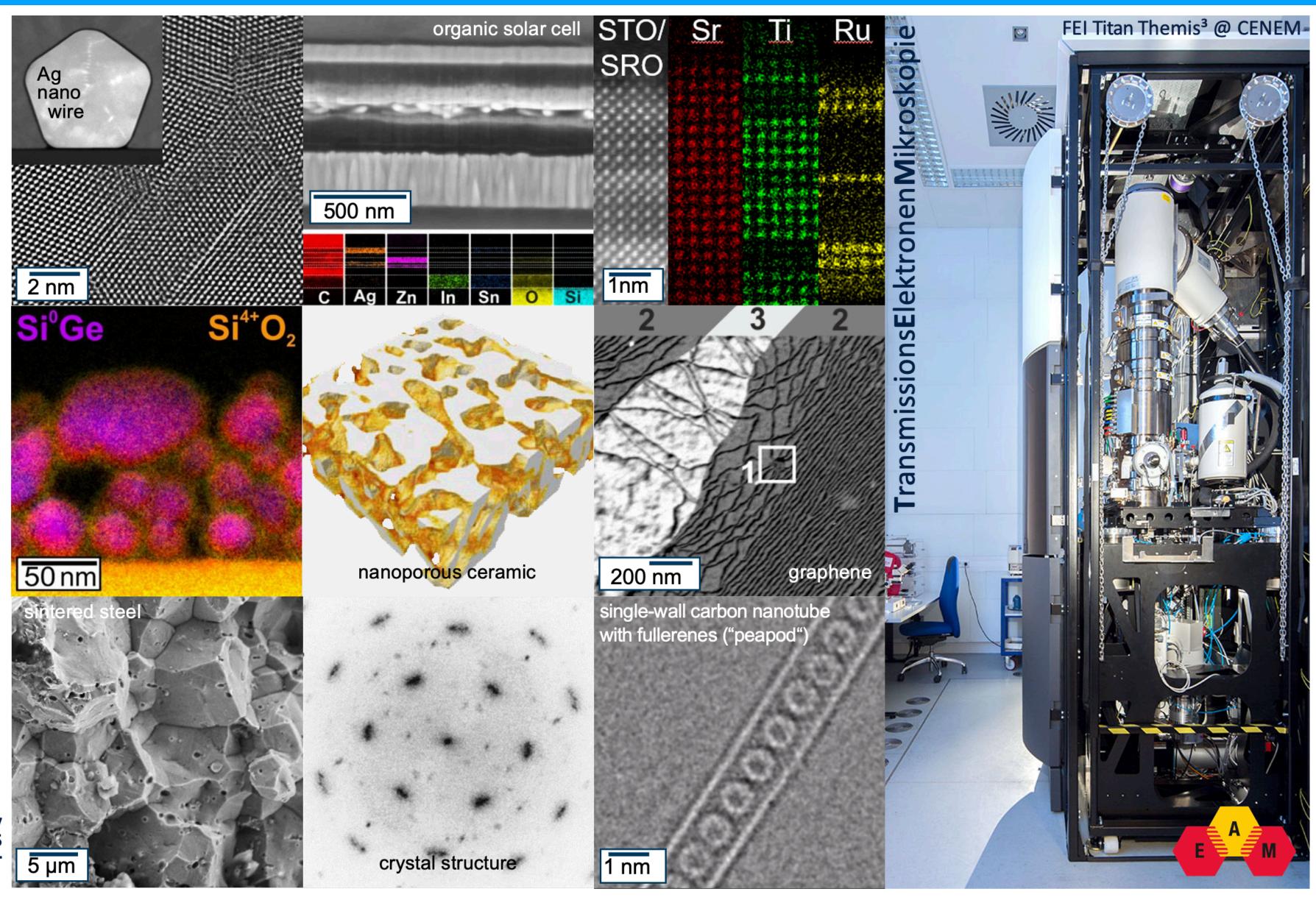


## Nanoanalytics

## Methods portfolio

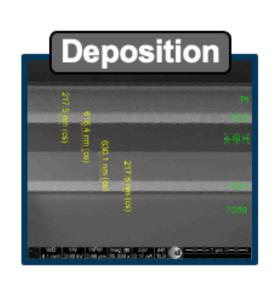
Materials/
device research
+
Methods
developments

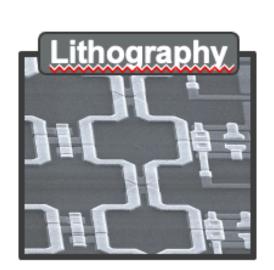
Adv Energy Mater '20 JACS '14 Energy Env Sci '18 Nanoscale '15 Nat Phys '15 ACS Photonics '19 Nature '14 Adv Energy Mater '13 Acta Mater '15



## Cleanroom Nanofacility

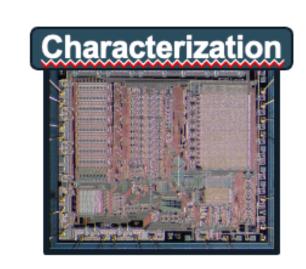


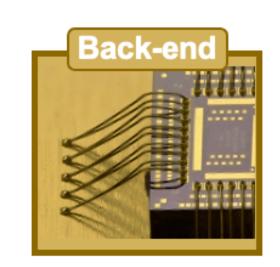




eBeam Litho

**Process chain** 







RIE

**ALD** 















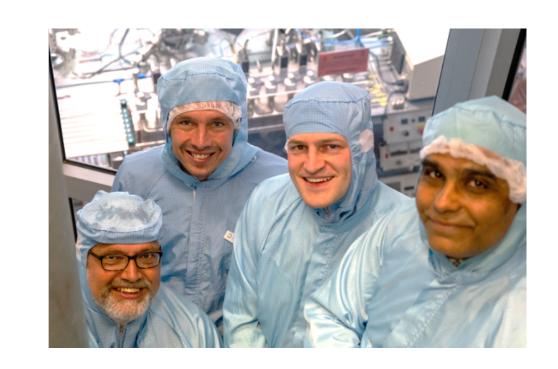






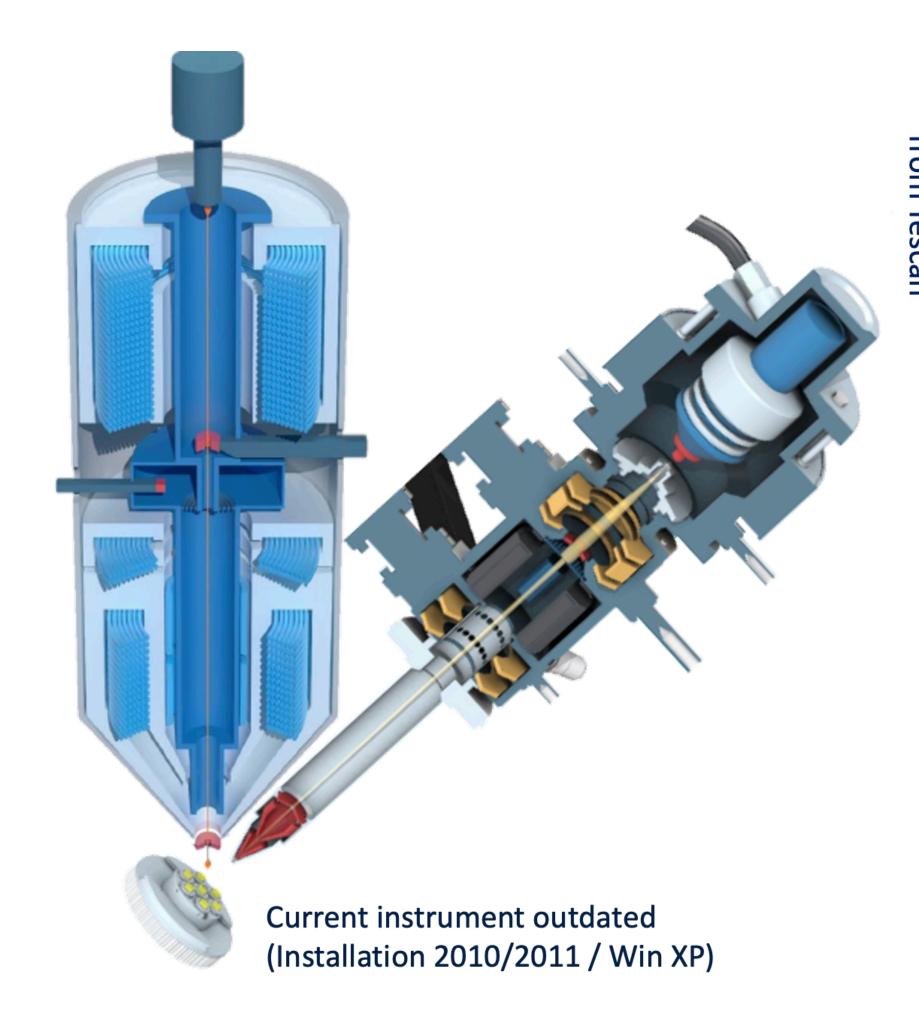
Nanotechnology facility

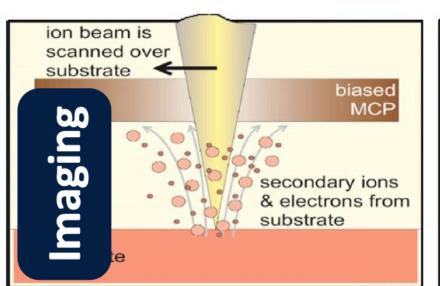
- 600 m² ISO4 cleanroom
- 300 m<sup>2</sup> Optoelectronics
- 150 m<sup>2</sup> HF-Sensorics

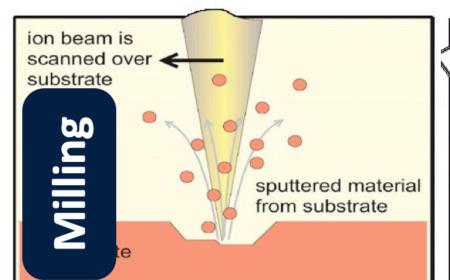


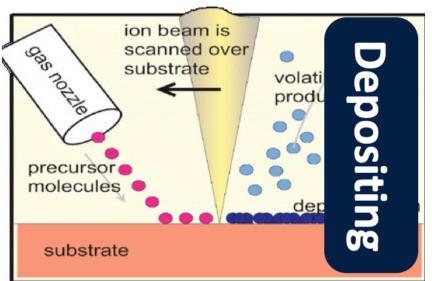
## Focused Ion-Beam instruments

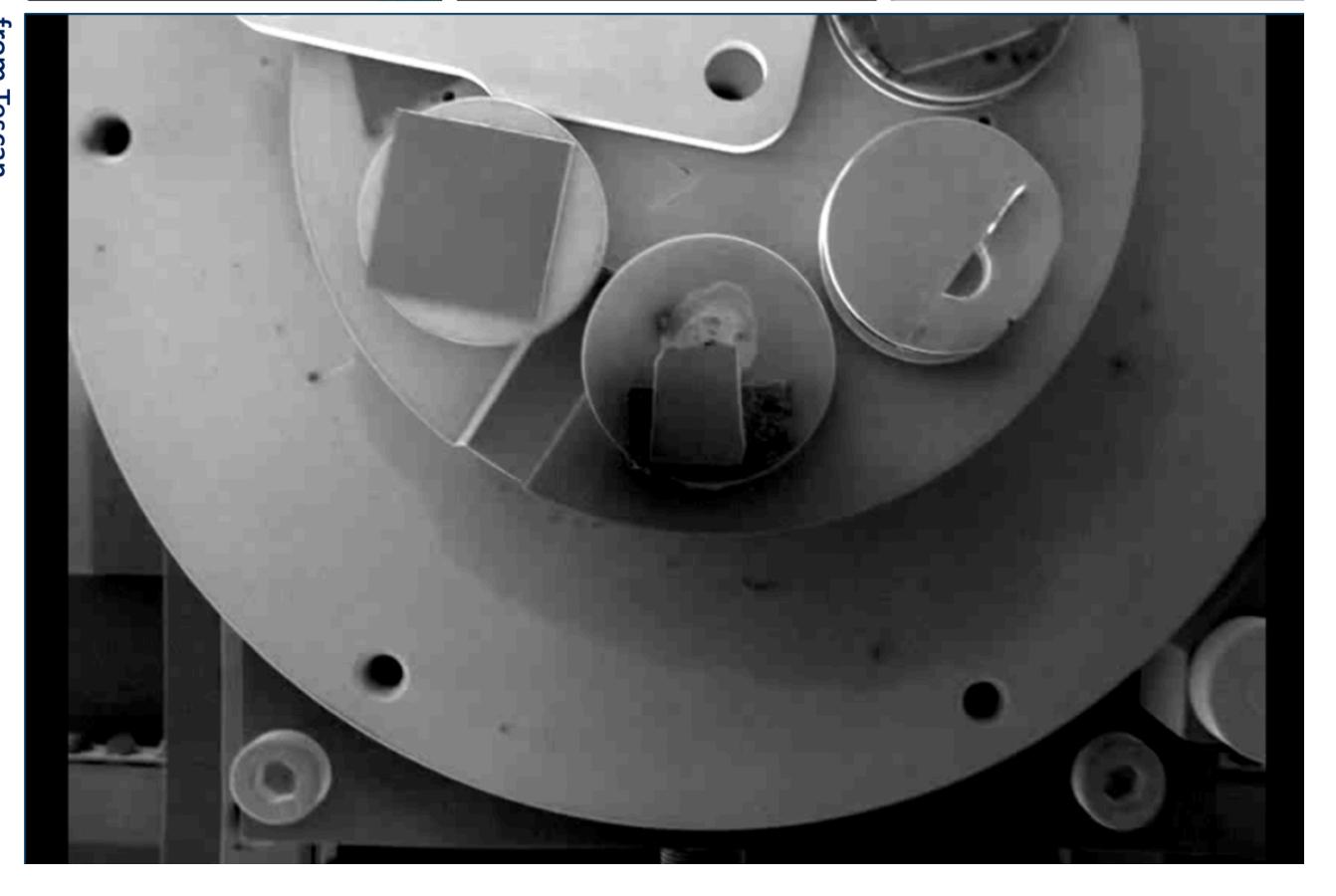
#### New FIB currently being installed





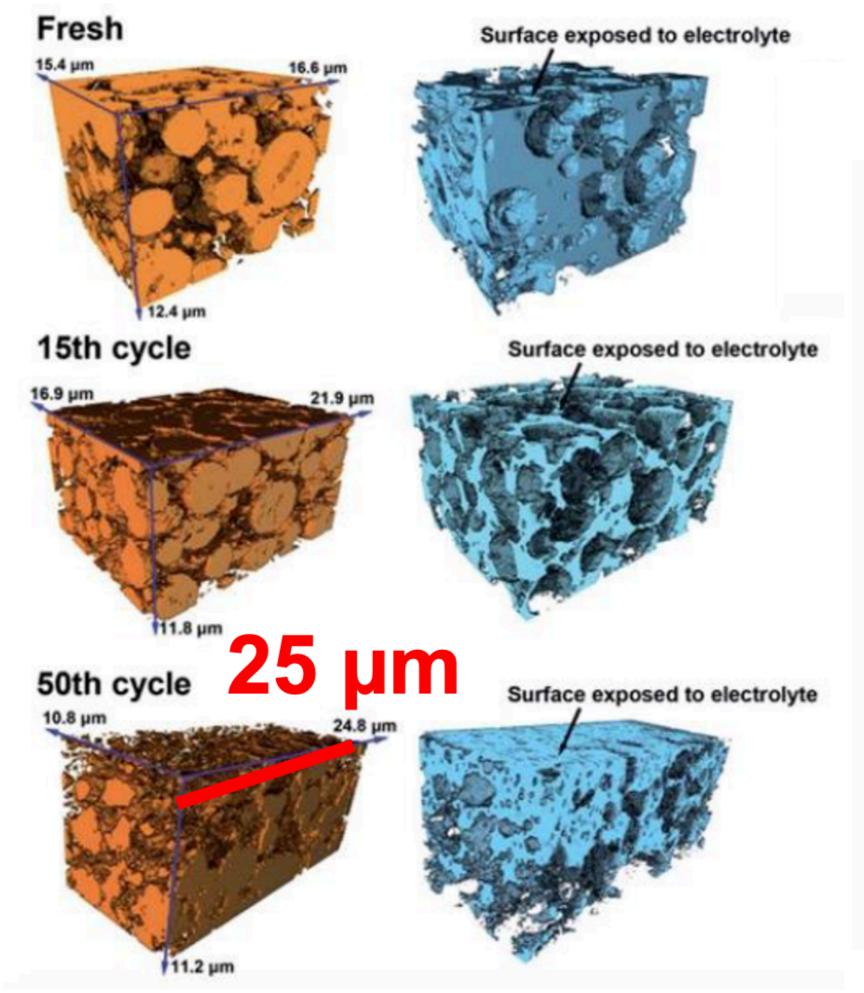






## Large-Scale Cross-Sectioning and 3D Characterization

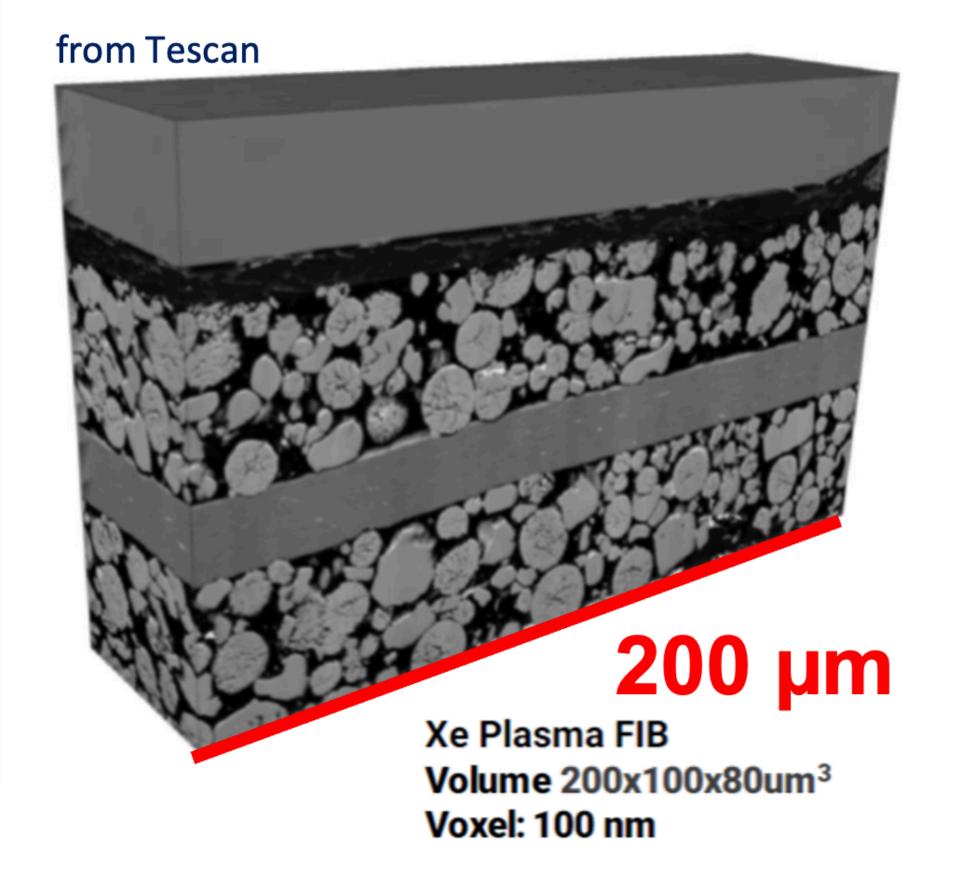
Some examples Ga-FIB



Ga FIB: Volume 10x10x20 um <sup>3</sup>

[1] B. Song, T. Sui et al., J. Mater. Chem. A, 35, 18171 (2015)

Xe-plasma FIB



## INCYTE

Central Infrastructure located at Universität Siegen

Focus on nanoanalytics, -chemistry and -technology

Shared use of core facilities

e.g. Nanotechnology facility and TEMs or FIBs for analytics

Excellence cluster activities very welcome

## Backup

## Materials and Surface Characterization Techniques

## Light Microscopy (LM)

• Uses visible light and optical lenses to image sample surfaces at the micron scale.

## Raster Electron Microscopy (REM / SEM)

• Scans the surface with a focused electron beam to produce detailed topographic and compositional images.

## Focused Ion Beam (FIB)

• Employs a beam of ions (often Ga<sup>+</sup>) to mill, cut, or deposit material with nanometer precision; often combined with SEM.

## Transmission Electron Microscopy (TEM)

• Transmits electrons through an ultrathin sample to reveal internal structure at atomic resolution.

## Aberration-Corrected Transmission Electron Microscopy (AC-TEM)

Advanced TEM with lens aberration correction for sub-angstrom imaging resolution.

## Materials and Surface Characterization Techniques

### X-ray Diffraction (XRD)

• Identifies crystal structure, phase composition, and lattice parameters from X-ray scattering patterns.

### Micro-Computed Tomography (µCT)

• Creates 3D images of internal structures using X-rays with micrometer-scale resolution.

#### Scanning Tunneling / Atomic Force Microscopy (STM / AFM)

• STM maps surfaces atom by atom via tunneling current; AFM measures surface topography via tip—sample forces.

#### X-ray Photoelectron Spectroscopy (XPS)

• Determines elemental composition and chemical states within the top few nanometers of a surface.

### Secondary Ion Mass Spectrometry (SIMS)

 Analyzes surface composition and depth profiles by sputtering atoms and measuring the ejected secondary ions.

#### Atom Probe Tomography (APT)

Provides 3D atomic-scale mapping of composition and structure via field evaporation and time-of-flight mass spectrometry.

